PPCMA

Integrated Pressure Controller with Mass Flow Meter



The PPCMA pressure controller with integrated mass flow meter provides pressure measurement and control while monitoring mass flow rates for critical process applications (e.g. backside wafer cooling) in a compact package that saves critical space when compared to the previous multicomponent systems necessary to accomplish the task.

The PPCMA utilizes leading Baratron® capacitance manometer technology for pressure measurement and patented thermal flow meter to monitor gas mass flow. Both are integrated along with a proportioning control valve and the latest in control electronics providing fast and accurate pressure control with critical flow monitoring as a system diagnostic. The PPCMA can be configured for 10 to 1000 Torr Full Scale pressure with a control range from 5 to 100% of Full Scale. The PPCMA pressure

controller is suitable for transport chamber pressure control, critical backside wafer pressure control and process gas panel pressure balancing as well as run-vent pressure control applications. The valve and flow meter can be configured for Full Scale flow rates from 5 to 5000 sccm Full Scale depending on process conditions.

The PPCMA is available with either digital (DeviceNet™ or EtherCAT®) I/O allowing for straightforward integration into new or retrofit applications. In-situ tuning and component diagnostics are enhanced through the device's micro USB user interface accessible via virtually any PC with a web browser.

Product Features

- Backside wafer cooling
- Fast response to set point with minimal overshoot
- Metal-sealed, cleanroom manufactured units meet critical high purity application needs
- Pressure measurement and control with flow metering in a single package requires less space and reduces system cost



Key Benefits

- Compact package
- Integral Baratron capacitance manometer technology provides accuracy, reliability, and wide range
- Patented mass flow sensor* provides exceptional long-term accuracy and zero stability

*Protected under the following U.S. patents: No. 6,779,394, No. 6,668,641, No. 6,810,308, No. 7,004,191 or International Patents and Patents pending.

Performance			
Pressure Type	Absolute		
Pressure Full Scale Ranges	10, 20, 50, 100, 200, 500 or 1000 Torr		
Transducer Over Pressure Limit	2x Full Scale for all ranges		
Maximum Differential Pressure	45 psid		
Burst Pressure	1500 psig		
Flow/Orifice Full Scale Ranges ¹	50, 200, 1000, 5000 (sccm)		
Control Mode	Downstream		
Pressure Measurement Accuracy	±0.5% of Reading		
Temperature Coefficients Zero Span	±0.02% of Full Scale/°C±0.04% of Reading/°C		
Pressure Readout Units ²	Torr, kPa, mbar, psi		
Pressure Resolution	0.1 Torr		
Pressure Control Accuracy ³	 ±1.0% of Reading (≥10% Full Scale) ±0.2% of Full Scale (<10% Full Scale) 		
Control Range	>5 to 100% of Full Scale		
Typical Response Time ⁴	<1.0 second (excluding system time constant)		
Flow Reading Full Scale Flow Rates (N₂ equivalent) Measurement Range Accuracy Repeatability Resolution	 5, 10, 20, 50, 100, 200, 500, 1000, 2000, 5000 2% to 100% of Full Scale ±1.0% of Reading >20% of Full Scale; ±0.2% of Full Scale (<20% of Full Scale flow) (including non-linearity, hysteresis, and non-repeatability referenced to 760 mmHg and 0°C) ±0.3 of Reading 0.1% of Full Scale 		
Temperature Coefficients Zero Span	<0.05% of Full Scale/°C<0.08% of Reading/°C		
Operating Temperature Range	10° to 50°C (50° to 122°F)		
Storage Temperature Range	-20° to 80°C (-4° to 176°F)		
Storage Humidity Range	0 to 95% relative humidity, non-condensing		

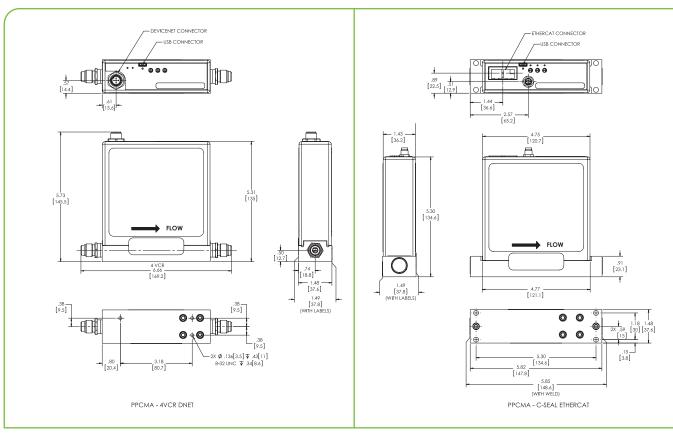
- Orifice Full Scale ranges are nominal Full Scale flow rates for Nitrogen with 15 psig on the inlet and atmosphere on the outlet side.
 Some readout units may not be available over every primary I/O.
 Accuracy includes linearity, hysteresis, and repeatability.
 Typical response time is excluding system time constant.

Mechanical			
Fittings		Swagelok® 4 VCR® Male, 1.5" surface mount (C-seal)	
Valve Options	Type Seat Material		
Leak Integrity	External (scc/sec He) Through Closed Valve	 <1 x 10⁻¹⁰ <1.0% of orifice Full Scale (Nitrogen at 25 psig on inlet to atmosphere) <0.1% of orifice Full Scale - Elastomer 	
Wetted Materials	Standard Optional (Valve Seat)	 316L S.S. VAR (equivalent to 316 S.S. SCQ for semiconductor quality), 316 S.S., Elgiloy®, KM-45, Inconel® 718, 825 Incoloy® PTFE (Teflon) or Elastomer (Viton) 	
Surface Finish		10 μinches, average Ra	
Weight		<5 lbs (1.36 kg)	

Note: The pressure controllers require flow to operate, and will not control pressure in "dead-ended" (zero flow) applications.



Digital I/O	DeviceNet™	EtherCAT [®]	
Input Power Required	+11 to +25 VDC per (< 4 watts)	+24 VDC (<5 watts)	
Connector	5 pin micro connector (power and comm.)	2 x RJ-45 (comm.) male, M8 male, 5 pin (power)	
Data Rate Switch/Selection	4 positions: 125, 250, 500K (Default), (programmable over network)	No switch	
Comm. Rate (s)	125 Kbps, 250 Kbps, 500 Kbps	100 Mbps	
MAC ID Switches/Addresses	2 switches, 10 positions; 0,0 to 6,3, 1 to 254	3 switches, 16 positions	
Network Size	Up to 64 nodes	Up to 4095 nodes	
Visual Indicators	LED Network (green/red) LED Module (green/red)	LED Power (green) LED Run (green) LED Error (red) LED Comm (green)	
Compliance	CE	CE	



Dimensional Drawings Unless specified, dimensions are nominal values in inches (mm referenced).



Ordering Code Example: PPCMA51T01102R8AV120	Code	Configuration
Model		
PPCMA Pressure Controller with Integral MFM	PPCMA	PPCMA
Pressure Range Full Scale and Units		
10 Torr 50 Torr 100 Torr 500 Torr 1000 Torr 1000 Torr 1000 mBar 500 mBar 1000 mBar 1 kPa 5 kPa 10 kPa 10 kPa	11T 51T 12T 52T 13T 12M 52M 13M 10K 50K 11K 12K	51T
Gas (Consult Factory For Other Gases)		
Helium (001) Argon (004) Hydrogen (007) Nitrogen (013)	01 04 07 13	01
Full Scale Flow Rate (sccm) - (minimum is 5 sccm N ₂ , equivalent)		
5 10 20 50 100 200 500 1000 2000 5000	500 101 201 501 102 202 502 103 203 503	102
Fittings		
Swagelok 4 VCR C-Seal	R C	R
Electrical Connector		
DeviceNet EtherCAT	6 8	8
Orifice Size		
A (50 sccm) #1 (200 sccm) #2 (1000 sccm) #3 (5000 sccm)	A 1 2 3	А
Plug Material		
Buna EPDM Neoprene Teflon Viton	B E N T V	V
Valve Type		
Normally Closed	1	1
Firmware		
DeviceNet EtherCAT	10 20	20

